

RECEIVED
CENTRAL FAX CENTER

MAY 04 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.	10/671,922
Confirmation No.	8459
Filing Date	September 24, 2003
Inventor	Garo J. Derderian et al.
Assignee	Micron Technology, Inc.
Group Art Unit	2812
Examiner	Lynne Ann Gurley
Attorney's Docket No.	MI22-2296
Customer No.	021567
Title: Atomic Layer Deposition Methods, and Methods of Forming Materials Over Semiconductor Substrates	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR § 1.8

I hereby certify that the following papers are being facsimile transmitted to the Patent and Trademark Office at 571-273-8300 on the date shown below:

1. Certificate of Facsimile Transmission
2. Response to February 23, 2006 Office Action

Dated: May 4, 2006

By:



Jennifer Gaines, Legal Assistant
Telephone No. (509) 624-4276
Facsimile No. (509) 838-3424

FEE DEFICIENCY

Although it is believed that no fees are due, the Commissioner is hereby authorized to charge any fees under 37 C.F.R. 1.16 and 1.17 which may be required by this paper to Deposit Account No. 23-0925.

Dated: May 4, 2006

By:



David G. Latwesen, Ph.D.
Reg. No. 38,533

NUMBER OF PAGES IN FACSIMILE: 11

MAY 04 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/671,922
Confirmation No. 8459
Filing Date September 24, 2003
Inventor..... Garo J. Derderian et al.
Assignee..... Micron Technology, Inc.
Group Art Unit..... 2812
Examiner Lynne Ann Gurley
Attorney's Docket No. MI22-2296
Customer No. 021567
Title: Atomic Layer Deposition Methods, and Methods of Forming Materials Over
Semiconductor Substrates

RESPONSE TO FEBRUARY 23, 2006 OFFICE ACTION

To: Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: David G. Latwesen, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

AMENDMENTS